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(Haeundae Beach) | Busan, Korea



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Dr. Satoshi Hamaguchi has been Professor at Osaka University, Osaka, Japan, since 2004, and now belongs to the Division of Materials and Manufacturing Science, Graduate School of Engineering. His research interest includes plasma processing for semiconductor processing, plasma medicine, nuclear fusion, and data-driven plasma science. Prior to joining Osaka University, he was Associate Professor at the Graduate School of Energy Sciences, Kyoto University, Kyoto, Japan, from 1998 to 2004, Research Staff Member of T. J. Watson Research Center, IBM Research Division, IBM Co. at Yorktown Heights, New York, USA, from 1990 to 1998, and Research Fellow at the Institute of Fusion Studies, University of Texas, Austin, Texas, USA, from 1988 to 1990. Dr. Hamaguchi received his M. Sci and Ph.D. degrees in mathematics from Courant Institute of Mathematical Sciences, Department of Mathematics, New York University, New York, USA, in 1986 and 1988, B. Sc. and M. Sci. in physics from the Department of Physics, University of Tokyo, Tokyo, Japan, in 1982 and 1984. He also holds a Ph. D. degree in physics from the University of Tokyo. He is a Fellow of the American Vacuum Society, American Physical Society, and Japan Society of Applied Physics.